| Application No. | Applicant(s) | 174 |
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| John A. McPherson | 1756 | |
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Conclusion

1. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

US 6,692,862 discloses a method of fabricating a color filter comprising the steps of forming a black matrix on a substrate, adhering a color transcription film to the substrate, disposing a laser head over the color transcription film, repeatedly scanning the color transcription film, and removing the color transcription film so that a color filter pattern remains in color filter regions defined inside the black matrix, wherein end lines for each one of the repeated scans are located on the black matrix.

US 5,981,112 discloses a method of making a color filter array comprising the steps of providing at least one transferable colorant on a second substrate positioned in transferable relationship but spaced apart from a first substrate, heating the second substrate to transfer the transferable colorant from the colorant layer to the first substrate, and removing unwanted colorant by a lift-off process, by chemical mechanical polishing, or by etching.

JP 10-090513 discloses a method for the production of a color filter comprising the steps of laser etching a light shielding layer to form patterns for red elements, coating with a red color resin, laser etching the light shielding layer to form patterns for green elements, coating with a green color resin, laser etching the light shielding layer to form patterns for blue elements, coating with a blue color resin, and removing unnecessary color resins laminated on the light shielding layer by polishing.

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Allowable Subject Matter

2. The following is an examiner's statement of reasons for allowance:

In a method of fabricating a color filter substrate for a liquid crystal display device comprising the steps of forming a black matrix on a substrate, adhering a color transcription film to the substrate, disposing a laser head over the color transcription film, repeatedly scanning a laser beam across a surface of the color transcription film using the laser head, and removing the color transcription film so that a color filter pattern remains within color filter regions defined by the black matrix, the prior art does not teach or suggest the step of polishing a surface of the color filter pattern to planarize a surface of the color filter pattern.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

3. Any inquiry concerning this communication or earlier communications from the examiner should be directed to John A. McPherson whose telephone number is (571) 272-1386. The examiner can normally be reached on Monday through Friday, 8:00 AM to 4:30 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Mark Huff can be reached on (571) 272-1385. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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John A. McPherson Primary Examiner Art Unit 1756

JAM 12/03/04